

2878



862.3157

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

4/I.D.S.
G. Stenly

In re Application of:)
MASAHIKO OKUNUKI) : Examiner: Not Yet Assigned 6-12-00
Application No.: 09/457,083) : Group Art Unit: 2878
Filed: December 7, 1999) :
For: ELECTRON BEAM) :
ILLUMINATION APPARATUS,) :
ELECTRON BEAM EXPOSURE) :
APPARATUS, AND DEVICE) :
MANUFACTURING METHOD) Date: June 6, 2000

Assistant Commissioner for Patents
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under
37 C.F.R. § 1.56 and in accordance with the practice under
37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is
directed to the document listed on the enclosed Form
PTO-1449. A copy of the listed document is also enclosed.

RECEIVED
JUN 12 2000
TC 2000 JUN 12 2000

The Examiner's attention is also directed to the following U.S. Application:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT.</u>
09/060,354	April 15, 1998	2778

In accordance with 37 C.F.R. § 1.98(a)(2)(iii), no copy of the cited U.S. Application is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be initialled and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should be directed to our new address given below.

Respectfully submitted,



Attorney for Applicant

Registration No. 42476

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